09/343 293 TRANSISTOR STRUCTURE HAVING SILICIDE SOURCE/DRAIN EXTENSIONS AND METHOD FOR MAKING SAME Peng Cheng, et al.

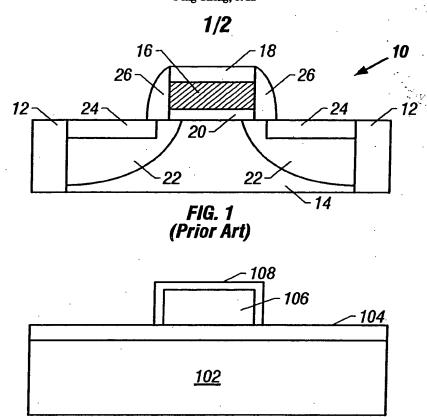
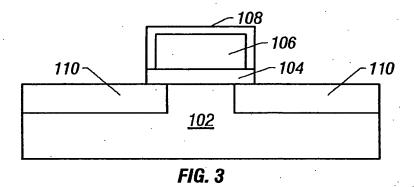


FIG. 2



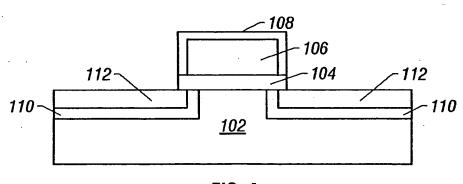


FIG. 4

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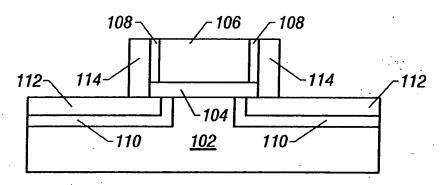
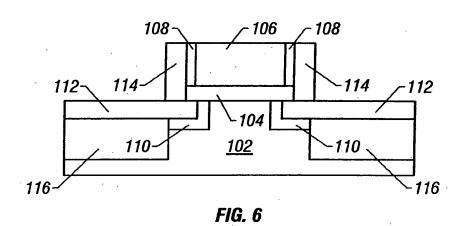


FIG. 5



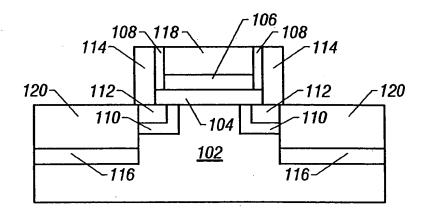


FIG. 7